



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **ATTN: BOX RCE**  
Akihisa HONGO et al. : **Confirmation No. 5731**  
Serial No. 09/762,582 : Docket No. 2001\_0133A  
Filed April 12, 2001 : Group Art Unit 1753  
SUBSTRATE PLATING METHOD AND : Examiner Brian Mutschler  
APPARATUS

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of

December 30, 2003.

The fee of \$110.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion which

() is enclosed.

() has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

04/20/2004 MAHMED1 00000008 09762582

02 FC:1251

110.00 OP

By

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April 16, 2004